



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yoshinori Hino et al.

Art Unit : 2826

Serial No. : 10/076,154

Examiner : Tan N. Tran

Filed : February 14, 2002

Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF SEPTEMBER 5, 2003

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

DECEMBER 4, 2003

Date of Deposit

Patricia F. Suchanek

Signature

PATRICIA F. SUCHANEK

Typed or Printed Name of Person Signing Certificate